

Attorney Docket: 071469-0309182
Client Reference: PC6042A2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 8235

PANDA SIDDHARTHA , ET AL.

Application No.: 10/821,201

Group Art Unit: 1763

Filed: April 9, 2004

Examiner: George A. GOUDREAU

Title: METHOD AND SYSTEM FOR DEEP TRENCH SILICON ETCH

REVISED AMENDMENT AFTER-FINAL

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In further response to the Office Action dated September 18, 2006, and in direct response to the Notice of Non-Compliant Amendment dated April 9, 2007, the date for response to which is May 9, 2007, please accept the following revised Amendment Under 37 C.F.R. § 1.116: